# Super-Fast Low Power (SFLP) SRAM Cell for Read/Write Operation

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#### **ABSTRACT**

In this paper a Super-Fast Low-Power (SFLP) static random access memory (SRAM) cell has been proposed. The SFLP cell contains two tail transistors in the pull-down path of the respective inverter to minimize the write power consumption The cell is simulated in terms of speed, power and read stability. The simulated results show that the read and write power of the proposed cell is reduced up to 38% and 55% at 1.2 V respectively and cell achieves 2.2x higher read static noise margin (SNM) compared to the conventional 6T SRAM cell.

#### **General Terms**

SRAM, delay, power, write margin, threshold voltage, SNM..

## Keywords

Static random access memory, PD-SOI, Write power, Write/read performance, Read SNM.

#### 1. INTRODUCTION

Due to requirement of light and portable devices, the demand high performance, low power digital very large scale integration (VLSI) system has increased [1-2]. In modern digital VLSI system, SRAM cell occupies a larger area on the chip. It is a great challenge to the researchers to restrict the power consumption in the modern processor due to demand of green technology. The power consumption of the systems can be reduced by reducing the power consumption of caches which occupies 60% to 70% of chip area. The power dissipated by caches is usually a major part of the total dissipated power. Due to this, design of power efficient high performance SRAM cell has gained importance. Various low power SRAM cell designs have been proposed [3-7]. Each design has its own merits and demerits. The cell stability is another important consideration for the cell designer [8,9].

In the present paper, a new Super-Fast Low-Power (SFLP) SRAM cell for read/write operation is proposed. The proposed cell is similar to the novel 8T SRAM cell except one extra transistor. This extra transistor is known as read access transistor, which is used to form the separate discharging path (read access transistor plus pull down transistor) during the read operation. Due to isolated read and write circuits, the read SNM of the proposed cell is enhanced. To avoid the any instability on the storage nodes in the unselected cells of the proposed 8T SRAM array, the switching behavior of the SFLP tail transistors are controlled by the respective storage nodes. During the write operation, the SFLP SRAM cell is similar to the Ref. [7] circuit which reduces the power consumption and reduces the write access time. The read operation is performed by only one bit line whereas write

operation is performed by two bit lines. Since, the discharging activity factor of the Super-Fast Low-Power (SFLP) cell is lower than the 6T cell, average read power consumption is 38% lower compared to the 6T SRAM cell. All the results are simulated in a CMOS 0.12μm technology using MICROWIND3 CAD tools [10]. The rest of the paper is organized as follows. In section 2, the operation of Super-Fast Low-Power (SFLP) cell is explained. Simulated results are discussed in section 3. Section 4 concludes the paper.

## 2. PROPOSED CIRCUIT DESCRIPTION

The complete schematic of the proposed Super-Fast Low-Power (SFLP) cell is shown in Fig. 1(a). The SFLP cell is divided into two circuits: write circuit and read circuit. The write circuit is similar to the 8T cell [7] and it is used to perform the write operation. The read operation is performed by two transistors (N7 and N5) which are used to perform the read operation. Transistor N7 is used to decouple the cell node from the read bit line during write operation/sleep mode. Due to this new design technique, the previously stored data remains intact in the cell during next write operation as long as RWL = 0. The layouts of the 6T and Super-Fast Low-Power (SFLP) SRAM cells, as shown in Fig. 1(b), are drawn in standard 0.12µm CMOS technology. The proposed SRAM cell has an area overhead of 11.7% due to additional two tail transistors. Because, the percentage of cell array to cache area is about 70%, the overall cache overhead is roughly (11.7% x70%) = 8.2% due to the proposed cell. The detail operation of the SFLP SRAM cell is:

During write operation read word line (RWL) is set to low so that write circuit completely decouples from the read circuit. The write operation in the proposed cell is performed by setting the bitlines (BL and BLB) to the desired logic. During write operation, the proposed SRAM cell behaves as the 8T cell [7]. In the SFLP cell, the switching behaviors of tail transistors are controlled by the respective logic on the storage nodes Q and nQ.

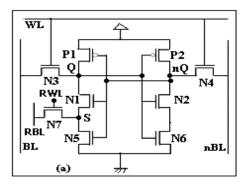


Fig 1: (a) SFLP SRAM cell

A read operation (RWL = 1, WL = 0) is performed by reading the data with help of the transistors N7 and N5. In read 1 operation, the transistor N5 is turned OFF, flips the node S to logic high, without allowing RBL to discharge which results lower power consumption. When node nQ stores data "1" (read 0 operation), transistor N5 turns ON. Now, the bitline (RBL) discharges through read access transistor N7 and pull down transistor N5. Since, storage nodes Q and nQ are completely isolated from bitlines during read operation; the voltage of the node which stores 0 is strictly maintained at the ground level.

# 3. SIMULATION RESULTS AND DISCUSSIONS

We have performed the simulation with help of BSIM4 model for 0.12 µm process technology. Threshold voltage of nMOS (pMOS) is set to 400mV. The 6T, Zero aware (ZA) [6], novel 9T (N.9T) [7], 8T [8], novel 8T (N.8T) [9] and SFLP cells are simulated and compared in terms of power consumption, access delay and current through each transistor. The simulated results are given in Tables (Table 1 -Table 7). In the proposed cell, overall power consumption is small compared to the 6T cell and other cells for  $1\rightarrow 1$  /0 $\rightarrow 0$ write pattern. This is due to the no state transition and reduced sub-threshold current. Subthreshold leakage current is small (Table 7) due to the stack effect. Stacking of transistors is an effective way to reduce the subthreshold leakage current [4]. In  $1\rightarrow 0/0\rightarrow 1$  write pattern, power consumption is reduced due to no discharging activity at bitline (Table 1). The power dissipated in bitlines is only a part of the total cache power consumption due to increase in height of the proposed cell. The tag bitlines contribute only about 3% to the total cache power consumption during write operation [6]. The increased power consumption in wordline of the proposed cell during write mode can be compensated by equalizing the width of SFLP cell and the 6T cell layouts. The proposed cell height is longer than the 6T cell that increases the bitlines capacitace from 27.76 fF for the 6T cell to 32.51 fF for the proposed array with 128 cells per column in 0.12 µm technology. The total column write power consumption reduced by 71.31% in the SFLP cell for  $0\rightarrow 0$  and  $1\rightarrow 1$  write transitions where as 37.8% column power reduction is observed for  $1\rightarrow 0$  and  $0\rightarrow 1$ write patterns in the SFLP cell due to two tail transistors in the write circuit.

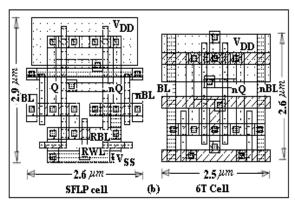


Fig 1: (b) Cell Layout

It is clear that the proposed SFLP SRAM cell consumes approximately 53.2% less average column write power (ACWP) than the conventional 6T SRAM cell. The  $1\rightarrow0/0\rightarrow1$  write transition speed of the proposed cell is faster than the conventional 6T cell and ZA cell (Table 1(a) &(b)), due to one OFF transistor in the pull down path of the inverter which lowers the discharging/charging time of bitlines. In the SFLP cell, a write operation can be performed for a minimum VWL value which is equal to the 0.56V instead of 0.81V as in the 6T cell (see Table 3). This indicates larger write margin of the proposed cell.

For read "1" operation (Q=1 & nQ=0), transistor N5 turned OFF and flips the node S to high. Due to no discharge at RBL considerable power is saved as seen in table 2. During read "0" operation, RBL discharges through two ON transistors N7 and N5. The average percentage read power reduction is 38% compared to the other cells (see Table 2). The read 1 access time is faster compared to the 6T cell (see Table 4). The read 0 delay is same compared to the conventional 6T cell. Table 7 gives the current flow through various transistors used in the 6T cell, 8T cell [7] and SFLP cell during read operation. Fig. 3 gives the variation of read power consumption with temperature for the 6-T cell and other cells. The proposed cell can be used up to T=120°C with minimal power loss. This smaller change in power consumption is due to absence of leakage paths during read operation and due to isolation of write circuit from read circuit in SFLP cell. Due to isolation of read and write circuits, the read stability is enhanced and node Q is maintained strictly at 0V for nQ=V<sub>dd</sub> (see Fig. 3)). The read SNM of the SFLP cell (420mV) is approximately 2.2xhigher than the SNM of the 6-T cell (195mV) and 1.3xlarger than the novel 8T cell [7] with a symmetrical butterfly curve. The use of low  $V_{TH}$  ( $V_{TH}$ =0.3V), transistors M7, M8 and M9 in the SFLP cell reduce the read SNM to 399mV compared to 110mV of novel 8-T cell. The SNM at different threshold voltages is given in Table 5. Due to increased change in current in current balance P1/N1 and P2/N2 at high temperature (T=120°C), read SNM decreases to 380mV from its room temperature value (Table 6). The percentage decrease in SNM temperature increases from 27°C to 120°C is only 9.5% in SFLP SRAM cell compared to 21% in novel 8T cell [7]. Fig. 2 gives the variation of read power consumption with temperature for the SFLP and the 6-T cells. The proposed cell can be used even in worse condition (T=120°C) with minimal power loss (10% in SFLP cell compared to 21% in novel 8T cell [7]). This smaller change in read power consumption is due to isolation of write circuit from read circuit in SFLP cell.

Table 1(a). Summary of write power for different input

	WRITE POWER (µW)					
	$0 \rightarrow 0$	$0 \rightarrow 1$	$1 \rightarrow 0$	$1 \rightarrow 1$		
6T	0.002	30.699	30.695	0.002		
ZA [6]	0.0025	31.498	6.646	0.0015		
N.9T[8]	0.002	31.488	31.487	0.002		
8T[7]	0.0005	18.195	18.191	0.0005		
N.8T[9]	0.002	7.201	31.513	0.001		
SFLP	0.0005	20.004	20.005	0.0005		

Table 1(b). Summary of write Delay

	WRITE DELAY(ps)					
	$0 \rightarrow 0$	$0 \rightarrow 1$	$1 \rightarrow 0$	$1 \rightarrow 1$		
6T	-	111	111	-		
ZA [6]	-	116	110	-		
N.9T[8]		114	114			
8T[7]		60	60			
N.8T[9]	-	121	117	-		
SFLP	-	62	62			

Table 2. Average read power and area

SRAM cells	Average read Power Consumption (µW)	Area (μm²)
6T	28.496	2.6x2.6
ZA[6]	30.379	2.6x2.9
N.9T [8]	25.510	2.6x3.3
8T [ 7]	31.586	2.6x2.9
N.8T[9]	24.327	2.6x3.4
SFLP	17.754	2.6x2.9

Table 3.Access transistor ( $I_{N4}$ ) current

$V_{WL}$	I <sub>N4</sub> in μA				
(volts)	6T	ZA	8T	LPF	SFLP
		[6]	[7]	[9]	
1.2	98	75	75	75	76
1.0	98	74	73	73	74
0.81	96	71	71	71	70
0.63	-	61	60	60	61
0.62	-	57	58	58	59
0.60	-	-	-	-	58
0.58	-	-	-	-	56

Table 4. Read Delay

SRAM cell	Read Delay (ps)		
	Read '0'	Read '1'	
6T	80	80	
ZA[6]	81	90	
N. 9T[8]	94	94	
8T [7]	90	90	
N.8T[9]	85	14	
SFLP	80	14	

Table 5. SNM for different VTH

V <sub>TH</sub>	SNM(mV)							
	6T ZA N.9T 8T N					SFLP		
		[6]	[8]	[7]	[9]			
0.3	-	106	352	110	359	399		
0.4	195	155	390	165	397	420		
0.7	-	398	433	405	443	465		

**Table 6. SNM with different Temperature** 

Temp	SNM(mV)					
(°C)	6T	ZA	N.9T	8T	N.8T	SFLP
		[6]	[8]	[7]	[9]	
-20	-	167	409	236	400	442
27	195	155	390	225	397	420
120	-	130	445	177	331	380

Table 7. Current through each transistor during write/read 0 operations

			WRITE OPERATION			READ OPERATION
		$0 \rightarrow 0$	$_0 \rightarrow _1$	$_{1}\rightarrow_{0}$	$_1 \rightarrow _1$	READ "0"
6T	I <sub>N3</sub>	0.623nA	0.051mA	0.100mA	0.623nA	0.043mA
	$I_{N4}$	0.623nA	0.100mA	0.051mA	0.623nA	0.312nA
	$I_{N1}$	1.623nA	0.050mA	0.039mA	24.61nA	0.042mA
	$I_{N2}$	24.61nA	0.039mA	0.050mA	1.623nA	0.312nA
N.9T[8]	$I_{N3}$	0.623nA	0.055mA	0.110mA	0.623nA	0.045mA
	$I_{N4} \\$	0.623nA	0.110mA	0.055mA	0.623nA	0.330nA
	$I_{N1}$	1.623nA	0.052mA	0.041mA	24.61nA	0.043mA
	$I_{N2} \\$	24.61nA	0.041mA	0.052mA	1.623nA	0.330nA
	$I_{N5}$	-	-	-	-	0.013mA
	$I_{N6} \\$	-	-	-	-	0.001mA
	$I_{N7}$	-	-	-	-	0.014mA
8T [7]	I <sub>N3</sub>	0.312nA	0.001mA	0.075mA	0.312nA	0.046mA
	$I_{N4}$	0.312nA	0.075mA	0.001mA	0.312nA	0.312nA
	$I_{N5}$	0.312nA	0.312nA	0.034mA	3.425nA	0.045mA
	$I_{N6}$	3.425nA	0.034mA	0.312nA	0.312nA	0.312nA
	$I_{N1}$	0.312nA	0.312nA	0.034mA	3.425nA	0.045mA
	$I_{N2}$	0.312nA	0.034mA	0.312nA	0.312nA	0.312nA
N.8T[9]	$I_{N3}$	-	-	-	-	-
	$I_{N4}$	0.623nA	0.075mA	0.051mA	0.312nA	0.312nA
	$I_{N1}$	1.623nA	0.312nA	0.039mA	3.425nA	0.045mA
	$I_{N2}$	24.61nA	0.034mA	0.050mA	0.312nA	0.312nA
	$I_{N5}$	-	-	-	-	0.013mA
	$I_{N6}$	-	-	-	-	0.001mA
	$I_{N7}$	-	-	-	-	0.014mA
SFLP	I <sub>N3</sub>	0.312nA	0.003mA	0.076mA	0.312nA	0.312nA
	$I_{N4}$	0.312nA	0.076mA	0.003mA	0.312nA	0.518nA
	$I_{N5}$	0.312nA	0.312nA	0.034mA	0.312nA	0.002mA
	$I_{N6}$	3.425nA	0.034mA	0.312nA	3.425nA	0.312nA
	$I_{N1}$	0.312nA	0.312nA	0.034mA	0.312nA	0.001nA
	$I_{N2}$	0.312nA	0.034mA	0.312nA	0.312nA	0.518nA
	$I_{N7}$	-	-	-	-	0.003mA

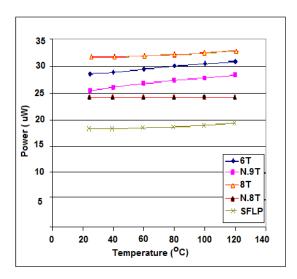
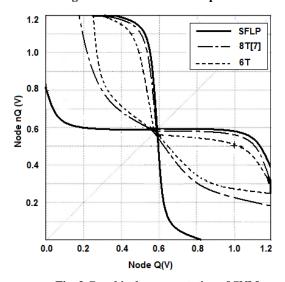


Fig. 2. Read Power with temperature



 ${\bf Fig.~3. Graphical~representation~of~SNM}$ 

#### 4. CONCLUSION

In the proposed cell, the power saves up to 55% during write operation and 38% during read operation compared to the 6T cell. The average column write power reduces in the SFLP SRAM cell. The SNM of the proposed SFLP cell is 2.2x higher than the 6-T cell and 1.3x the novel 8T cell. The SFLP cell and be used in worse condition ( $T = 120^{\circ}C$ ) with minimal power loss and stability loss.

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